



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al.  
Serial No. : 09/941,367  
Filed : August 28, 2001  
Title : METHOD FOR PRODUCING INSULATED GATE THIN FILM  
SEMICONDUCTOR DEVICE

Art Unit : 2814  
Examiner : Theresa T. Doan

#15/Amend 4  
7/12/03  
C.P.

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REPLY

In reply to the action mailed January 24, 2003, please amend the application as indicated on the following pages. Applicant asks that all claims be allowed in view of the amendment and remarks contained on the following sheets, a total of 7 pages.

Enclosed is a \$410.00 check for the Petition for Extension of Time fee. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: \_\_\_\_\_

6/23/2003

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